

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : U.S. National Stage of PCT/EP2004/012182
Confirmation No. :
Applicant : Wolfgang Babel et al.
Filed : May 11, 2006
Title : Sensor Arrangement with a Plurality of
Potentiometric Sensors
TC/A.U. :
Examiner :
Docket No. : BABE3004/FJD
Customer No. : 23364

INFORMATION DISCLOSURE STATEMENT

COMMISSIONER FOR PATENTS
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Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. A copy of each document listed on form PTO-1449 is submitted herewith (with the exception of the U.S. references). A copy of the International and the German Search Reports is attached.

This Information Disclosure Statement is submitted within three months of the filing date of the above-identified U.S. Patent application.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Respectfully submitted,

Date: May 11, 2006


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B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	Atty. Docket Number	Serial Number
	BABE3004/FJD	10/538865 Unassigned
	Applicant	
	Wolfgang Babel et al.	
	Filing Date	Group
	May 11, 2006	Unassigned

U.S. Patent Documents

Examiner Initial	Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate

Foreign Patent Documents

Examiner Initial	Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
						Yes	No
	WO 94/06005	17/Mar/94	WIPO				
	WO 03/052097 A1	26/Jun/03	WIPO				
	EP 1 460 130 A1	22/Sept/04	EPO				
	5 905 2745	27/Mar/84	EPO				
	DE 198 57 953 A1	06/Jul/00	Germany				

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

	I-Yu Huang et al., "Improvement of Integrated Ag/AgCl Thin-Film Electrodes by KC1-Gel Coating for ISFET Applications", 2003, Elsevier Science B.V.
	A. Poghosian et al., "Application of a (bio-)chemical sensor (ISFET) for the detection of physical parameters in liquids", 2003, Elsevier Science Ltd.
	C. Cane et al., "Microtechnologies for pH ISFET chemical sensors", 1997 Elsevier Science Limited.
	T.C. W. Yeow et al., "A very large integrated pH-ISFET sensor array chip compatible with standard CMOS Processes", 1997, Elsevier Science, S.A.
	H. Suzuki et al., "Micromachined liquid-junction Ag/AgCl reference electrode", 1998, Elsevier Science S.A.
	P. Bergveld, "Thirty Years of ISFETOLOGY What happened in the past 30 years and what may happen in the next 30 years", 2002 Elsevier Science B.V.

Examiner	Date Considered
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EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.